TO 76#1309022*1384#1703 P. 02/17

H4 Minutes Aford 2/28/ss

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No	09/602,395
	Julie 22, 2000
Inventor	John T. Moore
Assignee	Micron Technology, Inc.
Group Art Unit	2813
Examiner	Pham. T.
Attorney's Docket No.	MI22-1384
Title: Methods of Forming Oxide Regions Over Semiconductor Substrates	

RESPONSE TO DECEMBER 6, 2001 OFFICE ACTION

To:

Box Non-Fee Amendment

Assistant Commissioner for Patents

Washington, D.C. 20231

From:

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AMENDMENTS

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<u>In the Claims</u>

TECHNOLOGY CENTER 2800

Please replace the claims with the following clean version of the entire set of pending claims, in accordance with 37 C.F.R. § 1.121(c)(1)(i). Cancel all previous versions of any pending claim.

A marked up version showing amendments to any claims being changed is provided in one or more accompanying pages separate from this amendment in accordance with 37 C.F.R. § 1.121(c)(1)(ii). Any claim not accompanied by a marked up version has not been changed relative to the immediate prior version, except that marked up versions are not being supplied for any added claim or canceled claim.